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प्रभारी आचार्य (केन्द्रीय उपकरण केन्द्र)

Professor In-charge (Central Instrument Facility)

Ref. No.: IIT(BHU)/ CIF/2023-24/116

Date: 28/12/2023

Tender Amendment Notice

Tender Reference No.: IIT(BHU)/CIF/2023-24/100, dated 12/12/2023 and Tender ID No.: 2023_IITBU_785070_1 dated 12/12/2023 in Central Instrument Facility, IIT(BHU), Varanasi.

With reference to above mentioned Tender, due to minor error in Technical Specification the following amendment is requested:

Sl. No.	Specification Points	Amendment as:
A	In General requirements (page no. 34) under Technical Specification	
1.	The indentation process must be top-down i.e., the Indenter must be mounted vertically, and the sample is held horizontally on the XY stage.	"The indentation process must be mounted either vertically or horizontally, and the sample is held horizontally or vertically respectively on the test stage."
2.	Under Technical parameter 4.1: High speed nanoindentation: At least 1 indent per sec or better to allow property mapping (hardness and modulus maps)	"Rapid mapping should be possible with at least one indent every 5 seconds or better." to allow property mapping (hardness and modulus maps)

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